



THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3756**
Tomohiro OKUMURA et al. : Docket No. 2000_0191A
Serial No. 09/511,398 : Group Art Unit 1762
Filed February 23, 2000 : Examiner M. Padgett

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PLASMA PROCESSING METHOD AND
APPARATUS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of July 2, 2003, a three month extension of time having been obtained, please amend the above-identified application as follows.